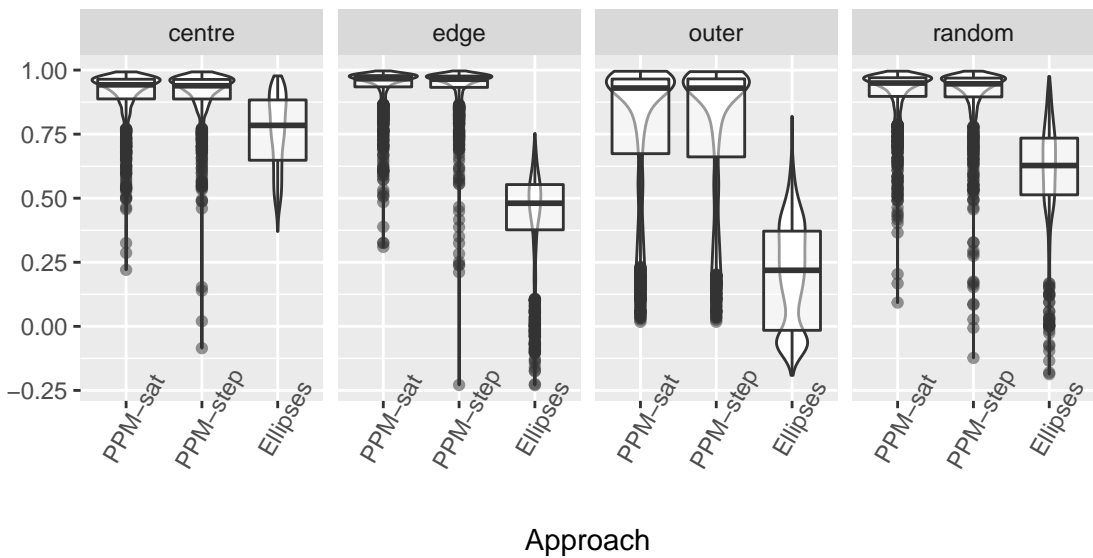


Correlation with generating surface



Approach